

# Complete Strain Mapping of Nanosheets of Transition Metal Dichalcogenides

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## ABSTRACT

Quasi-two-dimensional (quasi-2D) materials hold promise for future electronics because of their unique band structures that result in electronic and mechanical properties sensitive to crystal strains in all three dimensions. Quantifying crystal strain is a prerequisite to correlating it with the performance of the device, and calls for high resolution but spatially resolved rapid characterization methods. Here we show that using fly-scan nano X-ray diffraction we can accomplish a tensile strain sensitivity below 0.001% with a spatial resolution of better than 80 nm over a spatial extent of 100  $\mu\text{m}$  on quasi 2D flakes of 1T-TaS<sub>2</sub>. Coherent diffraction patterns were collected from a  $\sim$ 100 nm thick sheet of 1T-TaS<sub>2</sub> by scanning 12keV focused X-ray beam across and rotating the sample. We demonstrate that the strain distribution around micron and sub-micron sized ‘bubbles’ that are present in the sample may be reconstructed from these images. The experiments use state of the art synchrotron instrumentation, but are rapid and straightforward and present novel method for detailed strain mapping of thin samples.

## KEYWORDS

Quasi-2D materials, nano X-ray diffraction, strain tensor, strain mapping

## MAIN TEXT

The lattice degree of freedom profoundly affects the electronic properties of quasi-2D materials

ranging from graphene to transition metal dichalcogenides (TMDCs). The stacking of layers,<sup>1, 2, 3, 4</sup> in-plane strain<sup>5</sup> and strong electron-phonon coupling<sup>6, 7, 8</sup> amongst other factors determine the band structures, electron density of states as well as emergent charge orders<sup>9, 10, 11</sup> and superconductivity<sup>12</sup> in these materials. Moreover, quasi-2D materials are noted for their highly anisotropic mechanical properties, including superior strength<sup>13, 14</sup> in the 2D plane, and have been used as electromechanical resonators.<sup>15</sup> Both observations put the measurement of strains in a critical position - such measurements will provide the basis for quantifying and simulating all other material properties, both electronic and mechanical.

To date, nano-scale strains in quasi-2D materials have been measured almost exclusively using nano-indentation,<sup>13, 14, 16</sup> where an AFM tip exerts a force normal to the 2D plane in contact mode before it punctures through. This is an intrusive method and requires free-standing quasi-2D materials. Moreover, deriving the Young's modulus and strain from these measurements often involves rigorous modelling and certain presumptions such as the morphology of the free-standing membrane.

To achieve truly model-independent, non-destructive and spatial-resolved measurements of the strain tensor, we turn to diffraction-based methods. The key perspective is to consider the entire quasi-2D crystal as consisting of a nanoscale array of 2D "tiles" each with their own lattice parameter and orientations. Strain in the continuous material can then be viewed as originating from seamlessly connecting neighboring tiles. The differences in the lattice parameters and relative orientations of each tile are normally referred to as 'mosaic' in the crystallography terminology, and give rise to the movements of the Bragg peak, as well as the geometrical differences in satisfying the Bragg condition. We could capture the variation of Bragg peak positions by scanning a small X-ray beam across the sample. As for the Bragg condition, it is possible to vary the sample orientation at each position in real space and identify the scattering angles that maximize the Bragg peak intensity.

In this *Letter* we demonstrate strain mapping in quasi-2D 1T-TaS<sub>2</sub> flakes using X-ray nanodiffraction (nanoXRD). 1T-TaS<sub>2</sub> has been extensively studied as a model TMDC with multiple charge-ordered phases proximate to its onset of superconductivity. It is a Mott insulator with a  $\sqrt{13} \times \sqrt{13} \times 3$  commensurate charge order below 200 K and undergoes a first-order metal-insulator transition into the nearly commensurate charge ordered phase. Another phase transition occurs at 350 K into the incommensurate charge ordered phase with the ordering vector (0.283, 0, 1/3).<sup>12, 17</sup> Recent theoretical and experimental studies have suggested<sup>7, 11</sup> that the inter- and intra-layer strains and electron-phonon coupling impact the macroscopic properties of this material, including the formation and stability of the charge orders. Here we focus on the strain mapping at room temperature, in the nearly commensurate charge ordered phase.

Fig. 1 (a) depicts the X-ray nanodiffraction (nanoXRD) geometry. 1T-TaS<sub>2</sub> flakes were exfoliated mechanically and transferred to a 10  $\mu\text{m}$ -thick Si substrate. Details on material synthesis and sample preparation are described in the supplementary information. The nanoXRD measurements were performed at room temperature and  $\sim 300$  Torr helium gas (He) environment at the 3-ID

(Hard X-ray Nanoprobe) beamline of the National Synchrotron Light Source-II, Brookhaven National Laboratory.<sup>18, 19</sup> 12 keV monochromatic X-ray photons were focused by a Fresnel Zone Plate (FZP) onto the sample with a full-width-half-maximum of 80~100 nm. The X-ray fluorescence from the sample was collected using a Vortex detector 90° relative to the incident X-rays. The diffracted X-rays, transmitted through the sample and the thin substrate, were collected using a pixel-array detector (Merlin with Medipix3 chip) in a forward scattering geometry. A detailed description of the beamline and the sample pre-alignment procedure is described in the supplementary information and in ref. 19. A typical diffraction pattern is shown in Fig. 1(a). The diffraction intensity is distributed around a central dark region as is typical in coherent nano diffraction experiments.<sup>20, 21, 22, 23</sup> The definition of diffraction angles in this paper follows the convention used in a six-circle X-ray diffraction geometry,<sup>24</sup> as illustrated in Fig. 1 (a). Two angles – sample tilt and azimuthal rotation (not drawn) – are limited by the instrumentation and kept constant throughout the experiment. The Bragg condition is uniquely defined by the sample rotation  $\theta$  (with the rotation axis in the sample plane and normal to the experimental floor), the detector angles  $\delta$  and  $\gamma$ .

In Fig. 1 (b-e) we show the maps of the Ta L-edge fluorescence intensity and the integrated peak intensities on the area detector at a number of Bragg reflections. Maps shown here and elsewhere in this paper are collected by rastering in the sample plane with a dwell time of 0.1 seconds using the ‘fly-scan’ mode.<sup>25</sup> The continuous scan mode is chosen to minimize the scanning overhead associated with stop-start of the piezo stages.<sup>18</sup> Most prominent in Fig. 1 (c-e) are the circular regions with a meridional bar, resembling ‘coffee-beans’. The beans appear dark in their interior indicating a suppressed Bragg peak intensity. Since the Ta fluorescence does not show any changes in these regions, these observations collectively suggest that the missing intensities in the ‘coffee-bean’ regions are due to the sample locally not fully satisfying the Bragg condition.

To understand the nature of these ‘coffee bean’ profiles, we collected nanoXRD maps at a series of  $\theta$  angles. The summed intensities from the (1, 0, 0) Bragg peak are displayed in Fig. 2 (a-h) through a rocking curve. As the  $\theta$  angle increases monotonically, the bright parts develop from a single point (Fig. 2 (a)) to a deformed circle inside the left side of the coffee bean (Fig. 2 (b-c)). In Fig. 2 (d-e) the majority of the sample (which we refer to as the unperturbed region, as compared with those close to and within the ‘coffee bean’) meets the Bragg condition and exhibits maximum scattering intensity. From Fig. 2 (f) to (h), the right circumference of the coffee bean lights up, shrinks to a deformed circle and eventually a point inside the right side of the coffee bean. The  $\theta$  values marked on top of Fig. 2 (a-h) and throughout the rest of the paper are  $\theta$  angles relative to the Bragg angle of the unperturbed region. We further track the collected nanoXRD intensity vs.  $\theta$  angle at a series of locations across one of the ‘coffee beans’ (Fig. 2 (i)). Each of these curves take on a Lorentzian line shape. The full width half maximum of each Lorentzian profile is around  $\sim 0.2^\circ$ , corresponding to a correlation length of  $\sim 30$  nm. The centroids of the peaks are seen to undergo a resonance-like oscillation, distinct at each spatial location.

In Fig. 2 for any given location in the projected 2D sample plane, the Bragg diffraction intensity reaches a maximum when the location satisfies a specific Bragg condition. We consider each location as a small tile with independent lattice parameters and orientations. To quantify these

parameters at each location, we record the scattering geometry, including  $\theta$  as well as the position of the diffraction peak on the detector, conventionally denoted by the angles  $\delta$  (horizontal) and  $\gamma$  (vertical) (Fig. 1 (a)). In Fig. 3(a) we plot the  $\theta$  angle with maximum Bragg intensity (denoted as  $\theta_{\max}$ ). At  $\theta_{\max}$  we further determine the center of mass of the diffraction pattern (as shown in Fig. 1(a)) and show the horizontal and vertical component of the center of mass in Fig. 3 (b) and (c) (denoted as  $\delta(\theta_{\max})$  and  $\gamma(\theta_{\max})$ ). Notably, the maps of  $\delta(\theta_{\max})$  and  $\gamma(\theta_{\max})$  are found to be essentially featureless at the position of the coffee-beans. The diffraction angle between the incident and scattered X-ray photons almost does not change across the two-dimensional sample plane. This diffraction angle is directly determined by the lattice parameter via the Bragg law. In our case, the lack of modulation in the diffraction angle of the (1, 0, 0) Bragg peak indicates all the local 1T-TaS<sub>2</sub> tiles share almost identical in-plane lattice parameters,  $a$ , even within the coffee-bean region. Also note the (0, 0, 1) axis of the 1T-TaS<sub>2</sub> tiles is known to be roughly normal to the supporting silicon wafer across the entire sample. Thus, any in-plane twist around the (0, 0, 1) axis could lead to the combination of  $\delta(\theta_{\max})$  and  $\gamma(\theta_{\max})$  to rotate along the Debye-Scherrer ring. The lack of such motion means the local 1T-TaS<sub>2</sub> tiles are almost azimuthally aligned. Hence the modulation in  $\theta_{\max}$  as shown in Fig. 3(a) could only come from minor relative tilts between adjacent 1T-TaS<sub>2</sub> tiles along the  $c$  axis. In this sense, our nanoXRD studies present an independent and self-contained survey of the local crystalline lattice.

We now piece together these tiles into a sheet of 1T-TaS<sub>2</sub>. We expect the sample height function to be continuous, with the edges of neighboring tiles at the same sample height normal to the underlying silicon substrate. The difference in sample height between the mathematically infinitesimal tiles is

$$\frac{\partial h(x, y)}{\partial x} = \tan\theta_{\max}(x, y) \simeq \theta_{\max}(x, y) \quad (1)$$

where  $h(x, y)$  is the height of the sample along the  $z$  direction out of the quasi-2D plane and away from the underlying wafer.  $\theta_{\max}$  again is defined at each Bragg peak relative to the Bragg angle of the unperturbed region similar to elsewhere in this paper. The  $x$  and  $y$  directions are parallel to the detector  $\delta$  and  $\gamma$  angles at normal transmission respectively. We integrate in the quasi-2D plane

$$h(x, y) = \int^x \theta_{\max}(x', y) dx' \quad (2)$$

We derive the sample corrugation shown in Fig. 3(d). We can readily see that each of these coffee-bean shapes corresponds to a bubble-like, smooth one-sided deformation profile protruding above the substrate. Strictly speaking, equation (2) above only applies when the scattering plane is normal to the  $\theta$  rotation axis (Bragg peak (1, 0, 0) for the specific sample). For all the Bragg peaks we explored, the scattering plane (defined by the incident X-ray and the combination of  $\delta_{\max}$  and  $\gamma_{\max}$  angles) is always normal to the direction of the fine ‘meridional bar’ connecting two halves of the coffee bean in the corresponding intensity map shown in Fig. 1. Where the scattering plane is tilted relative to the  $\theta$  rotation axis, it could be mathematically shown that the 1D integration should be performed in the scattering plane.

Furthermore, these nanoXRD data are sufficient to allow direct calculation of the full strain tensor  $\varepsilon_{ij}$  from the deformation profile. We plot all the nonzero elements of the strain tensor in Fig. 3 (e-

i). Three of these terms,  $\varepsilon_{xx}$ ,  $\varepsilon_{yy}$ ,  $\varepsilon_{xy}$  (and  $\varepsilon_{yx}$ ), are proportional to  $\theta_{max}^2$ , or effectively zero if we only keep terms linear in  $\theta_{max}$ , reflecting extremely small changes in the lattice constants and d-spacings. This illustrates the high strain sensitivity of our nanoXRD method.  $\varepsilon_{yz/zx}$  are linear in  $\theta_{max}$  and are directly related to the sample rotation as we have so far ignored the thickness of our sample under the quasi-2D assumption.

We simulate the diffraction intensity of a Gaussian-like bubble protruding towards the incident X-ray at a series of  $\theta$  rotations in Fig. 4 (a-e), with the scattering plane containing the x-axis. Fig. 4 (a-e) are consistent with our experimental observations. Fig. 4 (f-j) presents the diffraction intensity maps with scattering plane rotating  $15^\circ$  relative to the z-axis pointing out of the x-O-y plane. Note the ‘meridional bar’ connecting the two halves of the ‘coffee-bean’ is always orthogonal to, and rotates with the scattering plane. The nano tiles along the ‘meridional bar’ have their scattering vectors lying parallel to the scattering plane, and thus have maximum diffraction intensity. This effect has been experimentally observed in Fig. 1 (c-e).

The formation of these micron and sub-micron size bubbles could be attributed in part to the intrinsic ‘softness’ of these materials in the Mermin-Wagner sense. The Mermin-Wagner theorem<sup>26</sup> states that no long-range lattice order can exist in two dimensions, because it is unstable to thermal fluctuations. Accordingly, perfect 2D materials in principle should not lie completely flat in the 2D plane, but extend into the third dimension. As bulk materials become thinner towards the quasi-2D limit, it appears plausible that the materials also become more prone to the kind of corrugations presented in this work. Equally possible in our case, as the quasi-2D sheets are prepared at ambient pressure, a small volume of gas may have been trapped underneath the sheet. Our nanoXRD was performed at around 0.3 bar helium gas environment, possibly leading to a net pressure difference between the two sides of the sheet.

We would like to compare our results with an electron diffraction version of strain mapping, which was recently demonstrated in refs. 27, 28. A major progress of that work, compared with previous scanning electron diffraction experiments, is to use a nano-sized electron source to avoid the complicated dynamical simulations needed for converging beam electron diffraction (CBED) studies. Still these electron diffraction methods are severely limited by the penetration depth of electrons and, furthermore, require samples to be in a free-standing geometry. In comparison, nanoXRD is well poised to study materials sealed as a device, with a top gate and/or a substrate. The spatial resolution of our nanoXRD approach is limited by the focused X-ray beam size (80 nm in this work), and could be improved using smaller X-ray beams (sub 10 nm in a state-of-the-art nanodiffraction facility such as the one where this work was performed<sup>18, 19</sup>), and also with the help of Bragg projection ptychographic reconstruction (1 nm as demonstrated in ref. 23). Indeed, our spatial resolution still lags behind electron and atomic force microscopes. On the other hand, as  $\sim 10$  keV X-ray photons have much smaller momentum than those of electrons in a typical electron microscope, nanoXRD generally features better strain sensitivity than its electron counterpart. As quasi-2D materials get thinner, current electron diffraction experiments are inherently even more limited to quantify the sample morphology in the third dimension, preventing a full description of the strain tensor.

The implications of our result will be significant when attempts are made in the future to assemble nano-scale heterostructures made from stacking quasi-2D materials on top of each other.<sup>29</sup> We suggest that nanoXRD could be a useful technique to understand the contacts formed between such quasi-2D materials and could have significant impact in that field.

## ASSOCIATED CONTENT

Supporting Information is available online.

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### Author Contributions

Y.C., I.K.R., S.B. and S.J.L.B. conceived the experiment. Y.C., T.A., S.B., Y.H., X.H., H.Y. and Y.S.C performed the nanoXRD measurement. Y.L., W.L. and Y.P.S. grew the bulk 1T-TaS<sub>2</sub> crystals. S.B., A.W., D.W. and A.P. further prepared the thin 1T-TaS<sub>2</sub> flakes used in the nanoXRD experiments. X.T. performed the atomic force microscopy characterization. Data analysis and interpretation was carried out by Y.C, I.K.R and S.J.L.B. Y.C. and I.K.R. wrote the majority of the paper with input from all coauthors.

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## FIGURES AND FIGURE CAPTIONS

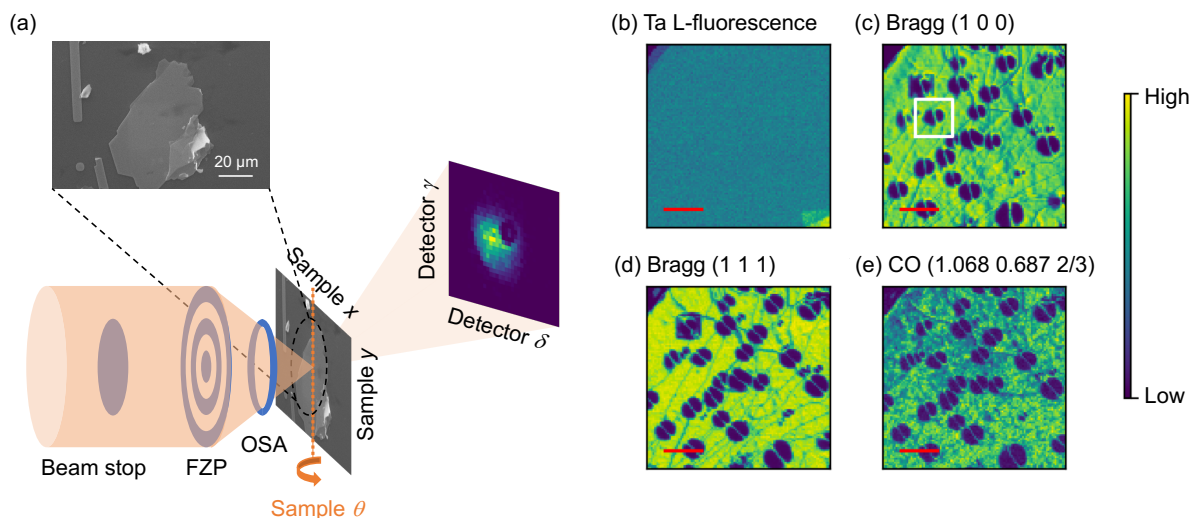


Figure 1: (a) The experimental setup. 12 keV coherent X-rays are focused using a Fresnel zone plate (FZP) and pass through an optical sorting aperture (OSA) onto the sample. The diffracted X-rays are collected using a pixel array detector behind the sample. The geometrical axes and coordinates used throughout the paper are as labeled. (b-e) shows the maps of (b) Ta L-edge fluorescence, (c-e) the total scattering intensity at Bragg  $(1, 0, 0)$ ,  $(1, 1, 1)$  and charge order  $(1.068, 0.687, 2/3)$  peaks. The red solid line corresponds to  $5\ \mu\text{m}$ . Each of (c-e) panels is collected at one respective  $\theta$  angle, which is defined crystallographically as where most of the 1T-TaS<sub>2</sub> sheet satisfies the respective Bragg condition.

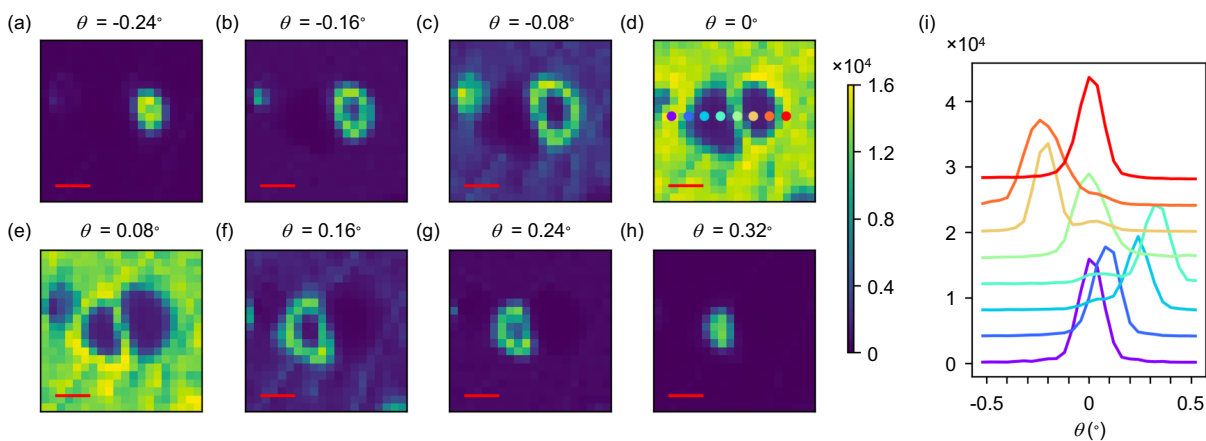


Figure 2: (a-h) NanoXRD diffraction intensity maps of the Bragg peak (1, 0, 0) at different  $\theta$  angles measured from a  $5 \mu\text{m} \times 5 \mu\text{m}$  area as marked using a white solid box in Fig. 1. The red solid line corresponds to  $1 \mu\text{m}$ . The  $\theta$  values are defined relative to the Bragg angle of the ‘unperturbed’ or flat region (the bright part in panel (d) outside the coffee bean). (i) The summed diffraction intensity vs.  $\theta$  angles at selected locations across the ‘coffee bean’. The curves are offset vertically for clarity. The colors of curves correspond the locations marked in panel (d).

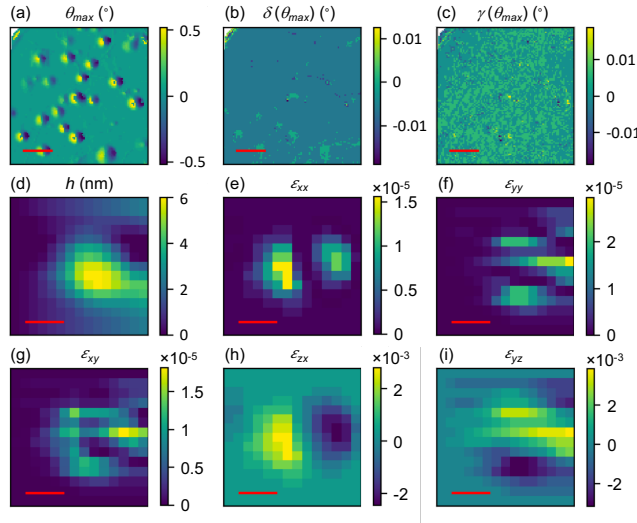


Figure 3: (a) The  $\theta$  angle with maximum Bragg (1, 0, 0) diffraction intensity at different locations on the 1T-TaS<sub>2</sub> nanosheet, labeled as  $\theta_{max}$ . (b-c) The center of mass of the diffraction pattern at  $\theta_{max}$  along detector angles  $\delta$  and  $\gamma$ , labeled as  $\delta(\theta_{max})$  and  $\gamma(\theta_{max})$ . All the units in (a-c) are in degrees, and the red scale bars correspond to  $5 \mu\text{m}$ . (d) The height of the sample normal to the quasi-2D plane, and normal to the underlying silicon wafer in the unit of nm. (e-i) Maps of all the nonzero and un-equivalent components of the elastic tensor calculated from the sample height in (d). Three of these terms,  $\epsilon_{xx}$ ,  $\epsilon_{yy}$ ,  $\epsilon_{xy}$  (e-g), are second order terms, while  $\epsilon_{zx}$  and  $\epsilon_{yz}$  (h-i), are linear terms. All the scale bars in (e-i) are  $1 \mu\text{m}$ .



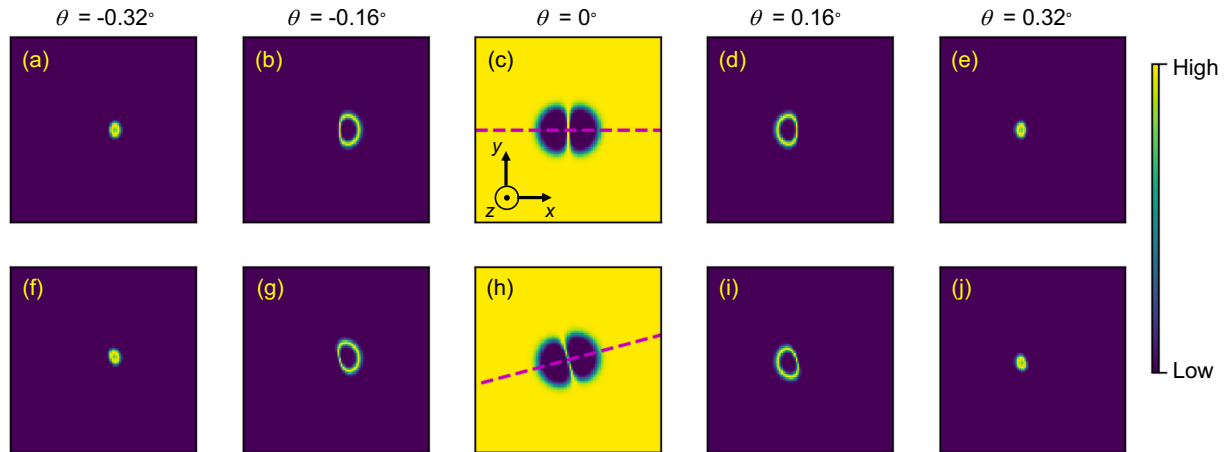


Figure 4: Simulated diffraction intensity maps from a 5 nm-high nanobubble at a series of  $\theta$  angles. The scattering planes in (a-e) are in the  $z$ - $O$ - $x$  and in (f-j) are  $15^\circ$  rotated counterclockwise around the  $z$  axis. Projections of the scattering planes in the quasi-2D plane are marked using dashed purple lines in (c) and (h) respectively.

## REFERENCES

- <sup>1</sup> Ohta, T.; Bostwick, A.; McChesney, J. L.; Seyller, T.; Horn, K.; Rotenberg, E. “Interlayer Interaction and Electronic Screening in Multilayer Graphene Investigated with Angle-Resolved Photoemission Spectroscopy”, *Phys. Rev. Lett.* **2007**, 98, 206802.
- <sup>2</sup> Zhang, Y. et al. “Direct observation of the transition from indirect to direct bandgap in atomically thin epitaxial  $\text{MoSe}_2$ ”, *Nat. Nanotechnol.* **2014**, 9, 111–115.
- <sup>3</sup> Ugeda, M. M.; Bradley, A. J.; Shi, S.-F.; da Jornada, F. H.; Zhang, Y.; Qiu, D. Y.; Ruan, W.; Mo, S.-K.; Hussain, Z.; Shen, Z.-X.; Wang, F.; Louie, S. G.; Crommie, M. F. “Giant bandgap renormalization and excitonic effects in a monolayer transition metal dichalcogenide semiconductor”, *Nat. Mater.* **2014**, 13, 1091.
- <sup>4</sup> He, J.; Hummer, K.; Franchini, C. “Stacking effects on the electronic and optical properties of bilayer transition metal dichalcogenides  $\text{MoS}_2$ ,  $\text{MoSe}_2$ ,  $\text{WS}_2$ , and  $\text{WSe}_2$ ”, *Phys. Rev. B* **2014**, 89, 075409.
- <sup>5</sup> Naumis, G. G.; Barraza-Lopez, S.; Oliva-Leyva, M.; Terrones, H. “Electronic and optical properties of strained graphene and other strained 2D materials: a review”, *Rep. Prog. Phys.* **2017**, 80, 096501.
- <sup>6</sup> Johannes, M.; Mazin, I. “Fermi surface nesting and the origin of charge density waves in metals”, *Phys. Rev. B* **2008**, 77, 165135.

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- <sup>7</sup> Liu, A. Y. “Electron-phonon coupling in compressed 1T-TaS<sub>2</sub>: Stability and superconductivity from first principles”, *Phys. Rev. B* **2009**, 79, 220515 (R).
- <sup>8</sup> Ge, Y.; Liu, A. Y. “First-principles investigation of the charge-density-wave instability in 1T-TaSe<sub>2</sub>”, *Phys. Rev. B* **2010**, 82, 155133.
- <sup>9</sup> Vaskivskiy, I.; Gospodaric, J.; Brazovskii, S.; Svetin, D.; Sutar, P.; Goreshnik, E.; Mihailovic, I. A.; Mertelj, T.; Mihailovic, D. “Controlling the metal-to-insulator relaxation of the metastable hidden quantum state in 1T-TaS<sub>2</sub>”, *Science advances* **2015**, 1, e1500168.
- <sup>10</sup> Gan, L.-Y.; Zhang, L.-H.; Zhang, Q.; Guo, C.-S.; Schwingenschlögl, U.; Zhao, Y. “Strain tuning of the charge density wave in monolayer and bilayer 1T-TaS<sub>2</sub>”, *Phys. Chem. Chem. Phys.* **2016**, 18, 3080–3085.
- <sup>11</sup> Zhao, R.; Wang, Y.; Deng, D.; Luo, X.; Lu, W. J.; Sun, Y.-P.; Liu, Z.-K.; Chen, L.-Q.; Robinson, J. “Tuning Phase Transitions in 1T-TaS<sub>2</sub> via the Substrate”, *Nano Lett.* **2017**, 17, 3471–3477.
- <sup>12</sup> Sipos, B.; Kusmartseva, A. F.; Akrap, A.; Berger, H.; Forró, L.; Tutiš, E. “From Mott state to superconductivity in 1T-TaS<sub>2</sub>”, *Nat. Mater.* **2008**, 7, 960.
- <sup>13</sup> Lee, C.; Wei, X.; Kysar, J. W.; Hone, J. “Measurement of the Elastic Properties and Intrinsic Strength of Monolayer Graphene”, *Science* **2008**, 321, 385–388.
- <sup>14</sup> Cooper, R. C.; Lee, C.; Marianetti, C. A.; Wei, X.; Hone, J.; Kysar, J. W. “Nonlinear elastic behavior of two-dimensional molybdenum disulfide”, *Phys. Rev. B* **2013**, 87, 035423.
- <sup>15</sup> Bunch, J. S.; Van Der Zande, A. M.; Verbridge, S. S.; Frank, I. W.; Tanenbaum, D. M.; Parpia, J. M.; Craighead, H. G.; McEuen, P. L. “Electromechanical Resonators from Graphene Sheets”, *Science* **2007**, 315, 490–493.
- <sup>16</sup> Bertolazzi, S.; Brivio, J.; Kis, A. “Stretching and Breaking of Ultrathin MoS<sub>2</sub>”, *ACS Nano* **2011**, 5, 9703–9709.
- <sup>17</sup> Chen, X.; Miller, A.; Nugroho, C.; de la Peña, G.; Joe, Y.; Kogar, A.; Brock, J.; Geck, J.; MacDougall, G.; Cooper, S.; Fradkin, E.; Van Harlingen, D. J.; Abbamonte, P. “Influence of Ti doping on the incommensurate charge density wave in 1T-TaS<sub>2</sub>”, *Phys. Rev. B* **2015**, 91, 245113.
- <sup>18</sup> Yan, H.; Bouet, N.; Zhou, J.; Huang, X.; Nazaretski, E.; Xu, W.; Cocco, A. P.; Chiu, W. K. S.; Brinkman, K. S. and Chu, Y. S. “Multimodal hard x-ray imaging with resolution approaching 10 nm for studies in material science”, *Nano Futures* **2018**, 2, 011001.
- <sup>19</sup> Nazaretski, E.; Yan, H.; Lauer, K.; Bouet, N.; Huang, X.; Xu, W.; Zhou, J.; Shu, D.; Hwu, Y. and Chu, Y.S. “Design and performance of an X-ray scanning microscope at the Hard X-ray Nanoprobe beamline of NSLS-II”, *J. Synchrotron Rad.* **2017**, 24, 1113-1119.
- <sup>20</sup> Godard, P.; Carbone, G.; Allain, M.; Mastropietro, F.; Chen, G.; Capello, L.; Diaz, A.; Metzger, T.H.; Stangl, J.; Chamard, V. “Three-dimensional high-resolution quantitative microscopy of extended crystals”, *Nat. Commun.* **2011**, 2, 568.

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- <sup>21</sup> Takahashi, Y.; Suzuki, A.; Furutaku, S.; Yamauchi, K.; Kohmura, Y.; Ishikawa, T. “Bragg x-ray ptychography of a silicon crystal: Visualization of the dislocation strain field and the production of a vortex beam”, *Phys. Rev. B* **2013**, 87, 121201.
- <sup>22</sup> Holt, M.V.; Hruszkewycz, S.O.; Murray, C.E.; Holt, J.R.; Paskiewicz, D.M.; Fuoss, P.H. “Strain Imaging of Nanoscale Semiconductor Heterostructures with X-Ray Bragg Projection Ptychography”, *Phys. Rev. Lett.* **2014**, 112, 165502.
- <sup>23</sup> Hruszkewycz, S.O.; Allain, M.; Holt, M.V.; Murray, C.E.; Holt, J.R.; Fuoss, P.H.; Chamard, V. “High-resolution three-dimensional structural microscopy by single-angle Bragg ptychography”, *Nat. Mater.* **2017**, 16, 244.
- <sup>24</sup> Lohmeier, M.; Vlieg E. “Angle calculations for a six-circle surface X-ray diffractometer”, *J. Appl. Crystallogr.* **1993**, 26, 706-716.
- <sup>25</sup> Huang, X.; Lauer, K.; Clark, J. N.; Xu, W.; Nazaretski, E.; Harder, R.; Robinson, I. K.; Chu, Y. S. “Fly-scan ptychography”, *Sci. Rep.* **2015**, 5, 9074.
- <sup>26</sup> Mermin, N.D.; Wagner, H. “Absence of Ferromagnetism or Antiferromagnetism in One- or Two-Dimensional Isotropic Heisenberg Models”, *Phys. Rev. Lett.* **1966**, 17, 1133.
- <sup>27</sup> Ozdol, V.; Gammer, C.; Jin, X.; Ercius, P.; Ophus, C.; Ciston, J.; Minor, A. “Strain mapping at nanometer resolution using advanced nano-beam electron diffraction”, *Appl. Phys. Lett.* **2015**, 106, 253107.
- <sup>28</sup> Han, Y.; Nguyen, K.; Cao, M.; Cueva, P.; Xie, S.; Tate, M. W.; Purohit, P.; Gruner, S. M.; Park, J.; Muller, D. A. “Strain Mapping of Two-Dimensional Heterostructures with Subpicometer Precision”, *Nano Lett.* **2018**, 18, 3746–3751.
- <sup>29</sup> Geim A. K.; Grigorieva I. V. “Van der Waals heterostructures”, *Nature* **2013**, 499, 419.

# Complete Strain Mapping of Nanosheets of Transition Metal Dichalcogenides

## Supplementary Information

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### Bulk sample synthesis

High-quality single crystals of 1T-TaS<sub>2</sub> were grown by the chemical vapor transport (CVT) method with iodine as a transport agent. The high-purity Ta (3.5 N) and S (3.5 N) were mixed in chemical stoichiometry and heated at 850°C for 4 days in an evacuated quartz tube. The harvested TaS<sub>2</sub> powders and iodine (density: 5 mg/cm<sup>3</sup>) were then sealed in another quartz tube and heated for 2 weeks in a two-zone furnace, in which the source zone and growth zone were fixed at 900°C and 800°C, respectively. The tubes were rapidly quenched in cold water to ensure retaining of the 1T phase.

### Nano flake preparation

Thin 1T-TaS<sub>2</sub> flakes were micromechanically exfoliated onto the scotch tape. The 10 μm-thick silicon substrates were carefully inverted and placed atop large areas of the crystal. Subsequently, the substrate was slowly peeled off from its longer edge and examined under an optical microscope to identify suitable patches of crystal that had adhered to the substrate, taking into account the sample size, shape, and uniformity. We measured the thickness of one 1T-TaS<sub>2</sub> flake with the Park NX20-SPM Atomic Force Microscope using the non-contact mode, and calibrated it against the 80 nm-high Pt fiducial mark on the same silicon wafer. The thickness of all other flakes was

determined using the Ta L-edge fluorescence intensity collected from the Vortex detector during the synchrotron experiment.

### **X-ray nanodiffraction (nanoXRD)**

Nanodiffraction measurements were performed using nano-Mii (Nanoscale Multimodal Imaging Instrument) at the Hard X-ray Nanoprobe Beamline of the NSLS-II.<sup>1, 2</sup> The 12 keV coherent incident X-rays are focused using a Fresnel zone plate with an outer ring width of 40 nm and outer diameter of 240  $\mu\text{m}$ . This gives an incident X-ray convergence of 2.58 mrad, or 0.15°. The X-ray beam focused by the Fresnel zone plate (FZP) was prepared using a central beam stop and an order sorting aperture (OSA). Under the condition of this experiment, the focused beam size was about 80 nm. The photon flux is estimated around  $2 \times 10^9$  photons/ $\mu\text{m}^2/\text{sec}$  at 12 keV. A pixel-array detector (Merlin, 55  $\mu\text{m}/\text{pixel}$ , 512 $\times$ 512 pixels), positioned 0.5 m downstream of the sample, was used to collect the diffracted x-rays. A schematic drawing of the experimental setup as well as the diffraction geometry (including the  $\theta$ ,  $\delta$  and  $\gamma$  angles) is displayed in Fig. 1(a) of the main text.

While the exfoliated 1T-TaS<sub>2</sub> often has edge facets indicating high-symmetry crystalline orientations, we need to self-consistently determine the crystal orientation during the nanoXRD experiments. This is achieved using a wide-angle Dexela CMOS X-ray detector (Dexela 1512NDT), mounted behind the Be exit-beam window of nano-Mii. The detector was pre-calibrated with Si wafer so that we could convert each pixel into the  $\delta$  and  $\gamma$  angles. By rotating (rocking) sample  $\theta$  we captured both the crystal Bragg peaks and charge ordered superlattice peaks on the detector with the corresponding  $\theta$ ,  $\delta$  and  $\gamma$  angles. We first filter the nanoXRD peaks by their two-theta values (i.e. d-spacings) and diffraction intensities, and then identify the crystal orientation by indexing the measured reflections using SPEC.<sup>3</sup> Nanodiffraction measurements with higher angular resolution and better detection sensitivity were carried out after removing the Dexela detector, allowing the diffracted x-rays to be transmitted to the Merlin detector. The nanoXRD data are collected using the fly-scan method as described in ref. 4. The data collection time per voxel is set to 0.1 seconds to prevent radiation damage. At least two consecutive fly-scans were taken at the same sample area to ensure there was no observable damage from the X-ray. Ta L-edge fluorescence was collected using a Vortex detector positioned at 90° relative to the incident X-rays.

We collected simultaneously both the nanoXRD patterns (as those plotted on the area detector shown in Fig. 1 (a)) and the fluorescence X-rays from the sample while performing 2D imaging scans. X-ray fluorescence data were analyzed using PyXRF.<sup>5</sup>

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<sup>1</sup> Yan, H.; Bouet, N.; Zhou, J.; Huang, X.; Nazaretski, E.; Xu, W.; Cocco, A. P.; Chiu, W. K. S.; Brinkman, K. S. and Chu, Y. S. “Multimodal hard x-ray imaging with resolution approaching 10 nm for studies in material science”, *Nano Futures* **2018**, 2, 011001.

<sup>2</sup> Nazaretski, E.; Yan, H.; Lauer, K.; Bouet, N.; Huang, X.; Xu, W.; Zhou, J.; Shu, D.; Hwu, Y. and Chu, Y.S. “Design and performance of an X-ray scanning microscope at the Hard X-ray Nanoprobe beamline of NSLS-II”, *J. Synchrotron Rad.* **2017**, 24, 1113-1119.

<sup>3</sup> Further information concerning the software could be found at: <https://www.certif.com/>.

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<sup>4</sup> Huang, X.; Lauer, K.; Clark, J. N.; Xu, W.; Nazaretski, E.; Harder, R.; Robinson, I. K.; Chu, Y. S. “Fly-scan ptychography”, *Sci. Rep.* **2015**, 5, 9074.

<sup>5</sup> Li, L.; Yan, H.; Xu, W.; Yu, D.; Heroux, A.; Lee, W.-K.; Campbell, S. I.; Chu, Y. S. “PyXRF: Python-based X-ray fluorescence analysis package”, *Proc. SPIE* **10389**, X-ray Nanoimaging: Instruments and Methods III, 103890U (2017).